## Kamon Aiempanakit

List of Publications by Year in descending order

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11 papers	33 citations	2258059 3 h-index	1872680 6 g-index
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11 all docs	11 docs citations	11 times ranked	19 citing authors

#	Article	IF	CITATIONS
1	Structural development and phase transformation behavior of thermally-oxidization Ti by sputtering power and OAD technique. Materials Chemistry and Physics, 2022, 280, 125814.	4.0	O
2	Electrochromism in Nanoporous Tungsten Trioxide Films Prepared through Anodization and Thermal Oxidation. Integrated Ferroelectrics, 2022, 222, 84-92.	0.7	1
3	Trace-level detection and classifications of pentaerythritol tetranitrate via geometrically optimized film-based Au/ZnO SERS sensors. Sensors and Actuators B: Chemical, 2022, 366, 131986.	7.8	9
4	Au-decorated ZnO nanorod arrays for SERS-active substrates towards trace detection and classification of pentaerythritol tetranitrate. Materials Today: Proceedings, 2021, 47, 3517-3524.	1.8	2
5	Effects of active area on UV detection by TiO2-sputtered films. Materials Today: Proceedings, 2021, , .	1.8	O
6	Effects of oblique angle deposition on optical and morphological properties of WO 3 nanorod films for electrochromic application. Materials Today: Proceedings, 2017, 4, 6423-6429.	1.8	8
7	Effect of Oxygen Flow Rate and Post Annealing on Vanadium Oxide Thin Films Prepared by DC Pulse Magnetron Sputtering. Key Engineering Materials, 2016, 675-676, 233-236.	0.4	1
8	CTAB as a soft template for modified clay as filler in active packaging. Data in Brief, 2015, 3, 47-50.	1.0	7
9	Effects of Annealing Treatment on WO <sub>3</sub> Thin Films Prepared by DC Reactive Magnetron Sputtering. Advanced Materials Research, 0, 979, 248-250.	0.3	2
10	Determination of Thickness and Optical Properties of Tantalum Oxide Thin Films by Spectroscopic Ellipsometry. Advanced Materials Research, 0, 979, 244-247.	0.3	3
11	Vertical Alignment TiO <sub>2</sub> Nanotube Based on Ti Film Prepared via Anodization Technique. Key Engineering Materials, 0, 675-676, 167-170.	0.4	O